



3790 USA/DISPLAY/AKT/RK
7828.7017

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KURITA, et al.

Serial No. 09/464,362

Filed: December 15, 1999

For: DUAL SUBSTRATE LOADLOCK
PROCESS EQUIPMENT

Group Art Unit: 1763

Examiner: McArthur, S.

PETITION FOR EXTENSION OF TIME

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with Rule 1.136, the applicant respectfully petitions the Commissioner for a three month extension of time extending to June 18, 2003, the period for response to the Office Action dated December 18, 2002. The \$930 fee and the responsive papers are attached. If it should be determined that a longer extension of time is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-0585. **A duplicate copy of this petition is enclosed.**

Respectfully submitted,

Alan S. Raynes
Reg. No. 39,809

Date: June 18, 2003

#17
7/13/03
MLW

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Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 18, 2003.

Alan S. Raynes

June 18, 2003
(Date)